Notice of Allowability	Application No. Applicant(s)		
	10/716,614	SHIMIZU, SATOSHI	
	Examiner	Art Unit	
	Fazli Erdem	2826	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. 1. This communication is responsive to Amendment filed on 12/07/04.			
<u> </u>	1 <u>2701704</u> .		
 2. The allowed claim(s) is/are 1-3. 3. The drawings filed on 23 June 2004 are accepted by the E. 	xaminer.	NATHAN J. FLYNN SUPERVISORY PATENT EXAMINER	
4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) TECHNOLOGY CENTER 2800			
a) ⊠ All b) ∐ Some* c) ∐ None of the:			
1. ☑ Certified copies of the priority documents have been received.			
 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 			
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.			
5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.			
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached			
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).			
7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)		f Informal Patent Application (PTO-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)		v Summary (PTO-413), No./Mail Date	
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date	8), 7. 🗌 Examin	er's Amendment/Comment	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examin 9. ☐ Other _	er's Statement of Reasons for Allowance	·

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DETAILED ACTION

Allowable Subject Matter

1. Claims 1-3 allowed.

2. The following is an examiner's statement of reasons for allowance: Prior art failed to

establish a semiconductor device with a semiconductor substrate, gate electrode with source and

drain, dummy electrode, a stopper insulating film, a sidewall insulating film, interlayer insulating

film, a linear contact portion defined by a conductive member extending from vertically in the

interlayer insulating film and electrically connected to one of the source and drain region at its

bottom end where the linear contact portion extends parallel to straight portion of the gate

electrode when viewed above where a gap between the gate electrode and the dummy electrode

appearing when viewed from above in linear contact portion being filled with sidewall insulating

film such that semiconductor substrate is not exposed.

Any comments considered necessary by applicant must be submitted no later than the

payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Fazli Erdem whose telephone number is (571) 272-1914. The

examiner can normally be reached on M - F 8:00 - 5:00.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan Flynn can be reached on (571) 272-1915. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

FE February 5, 2005